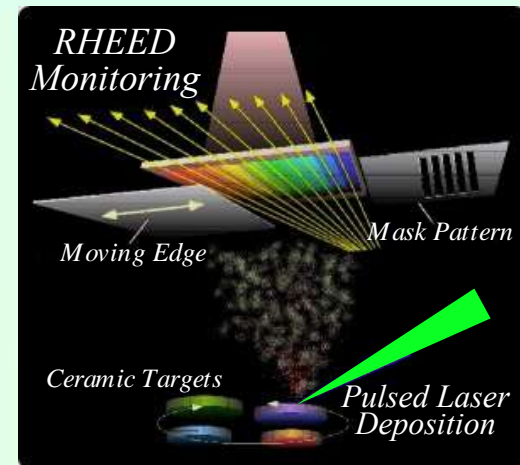
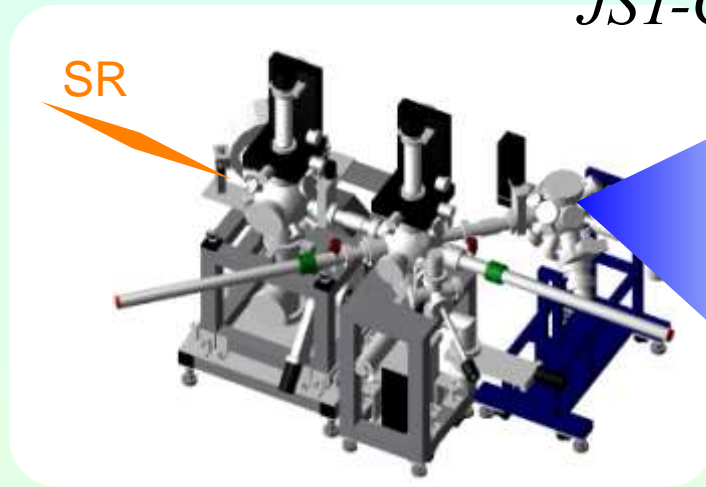


放射光電子分光でみる 酸化物へテロ界面電子状態

組頭 広志

東京大学大学院工学系研究科

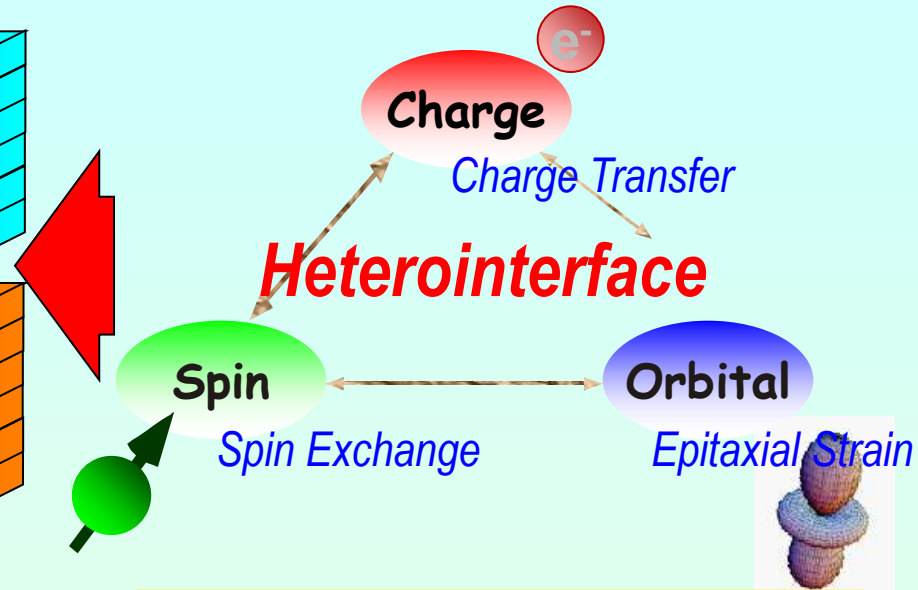
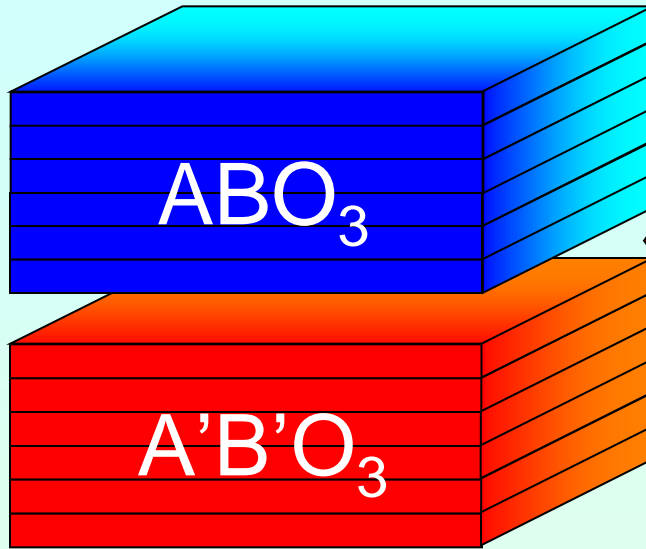
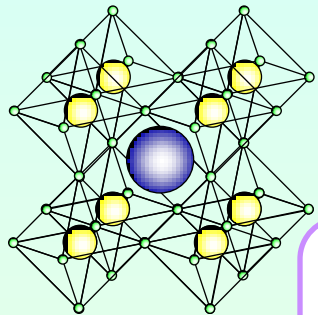
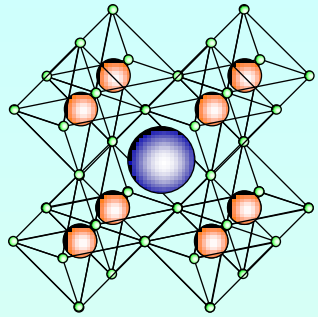
JST-CREST



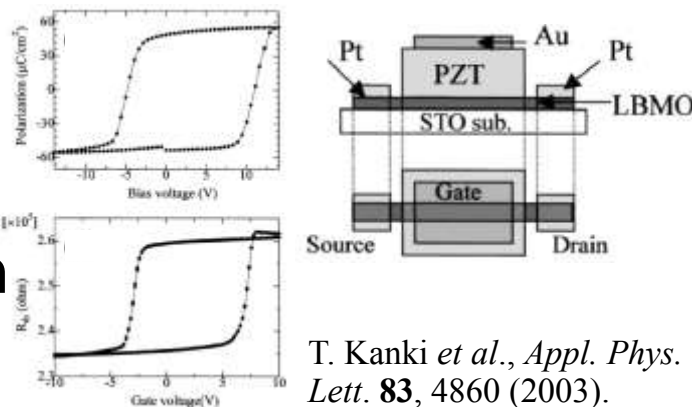
INTRODUCTION

Heterojunctions based on Perovskite Oxides

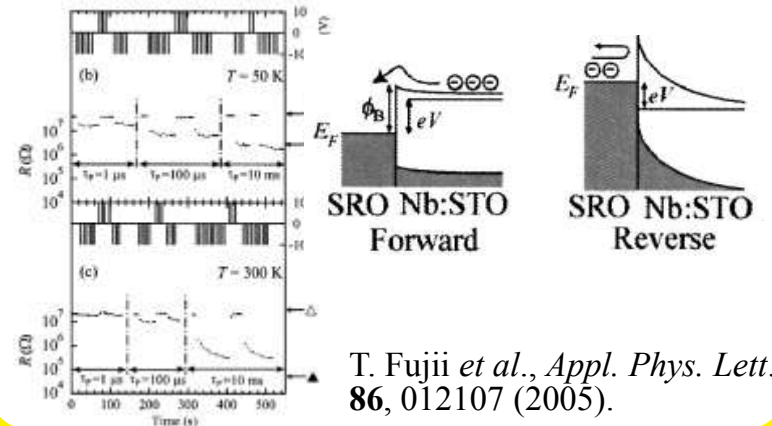
Controlling physical properties using interface effects



Ferroelectric FET



Resistance RAM



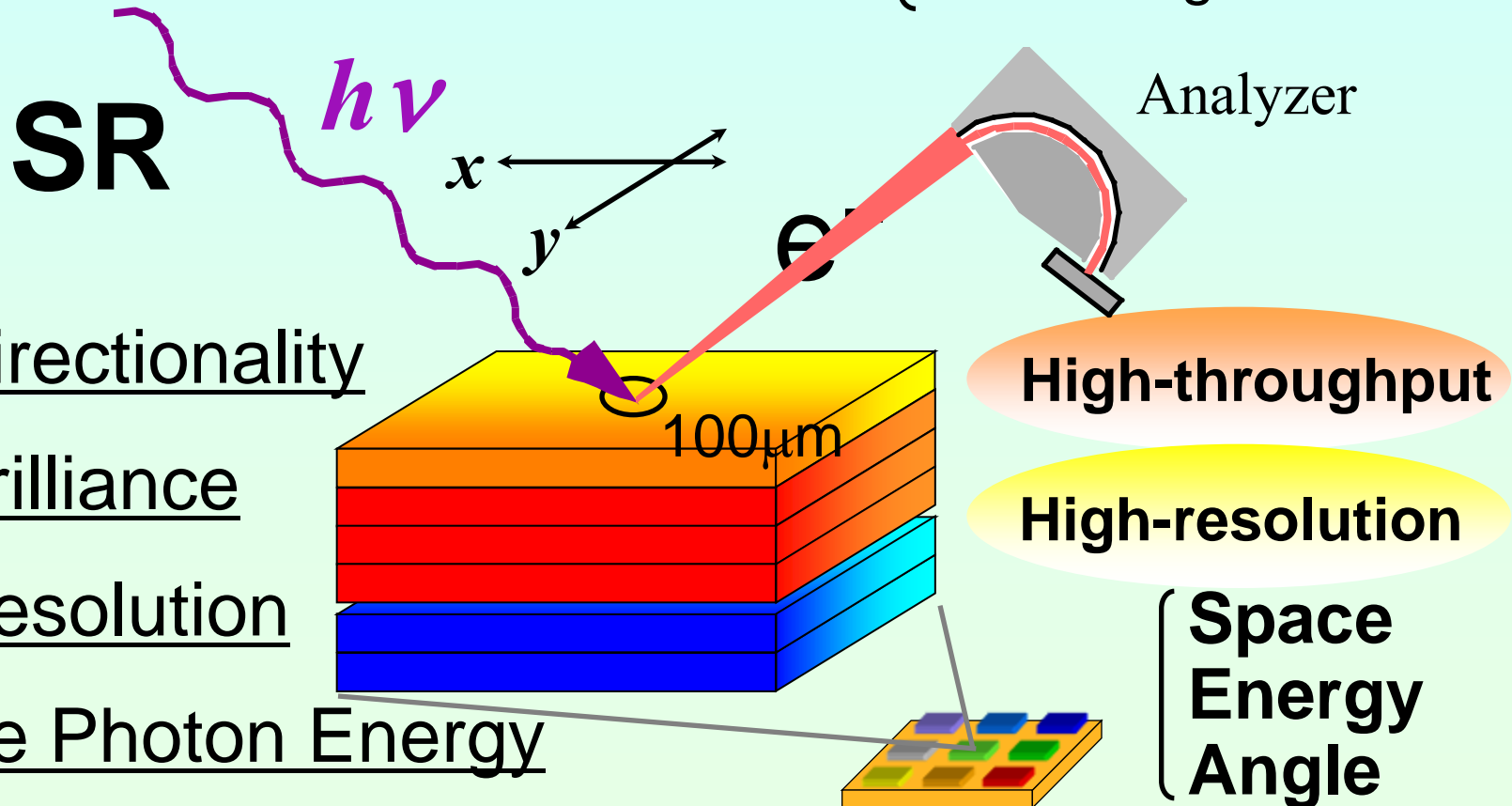
High T_c
CMR
MI transition

Advantage of SR-PES

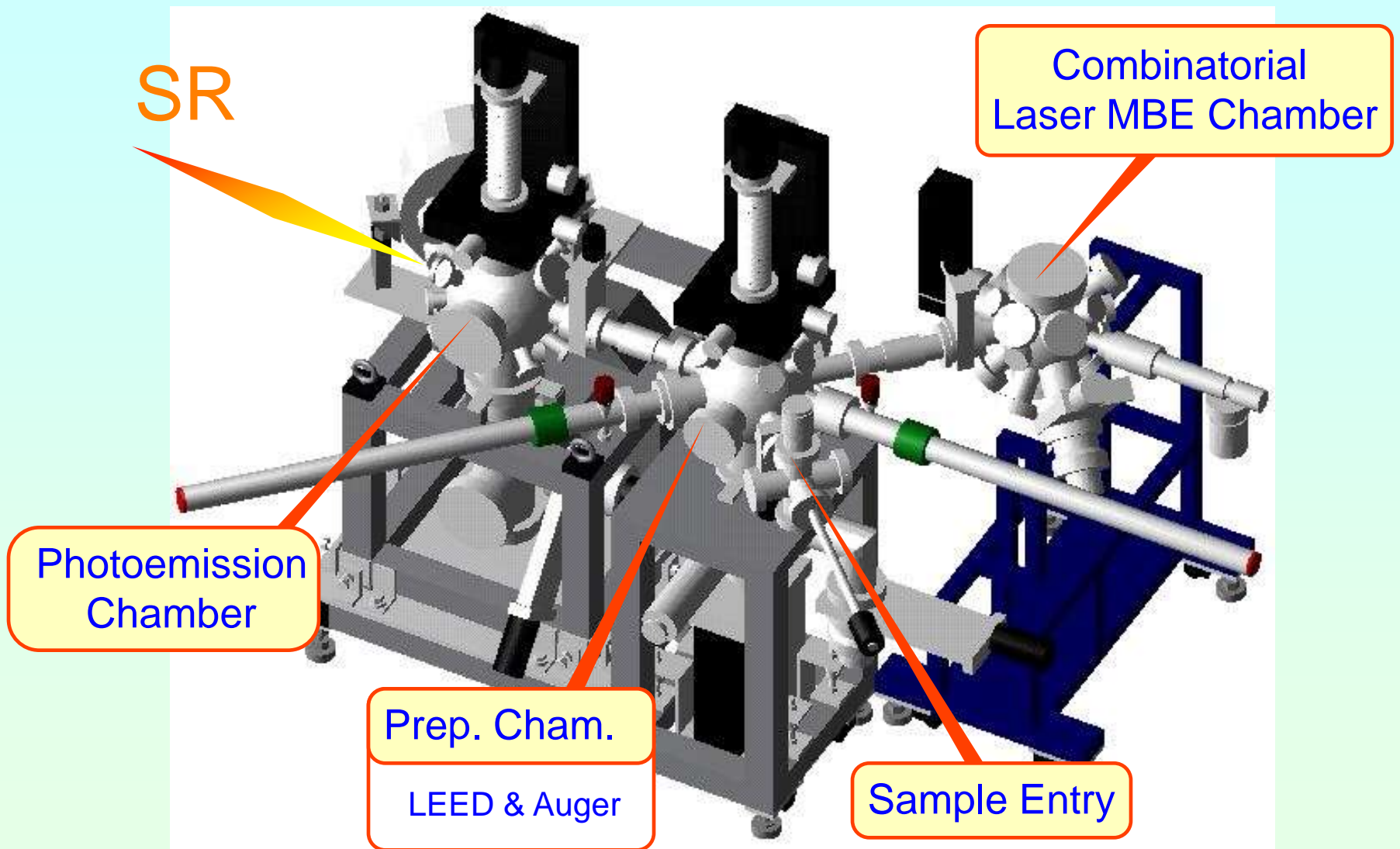
- ☆ Non-destructive
- ☆ Surface (Interface) Sensitive
- ☆ Direct Determination of Electronic States

Hard-XrayPES@SPring-8 ($\sim 1000 \text{ \AA}$)

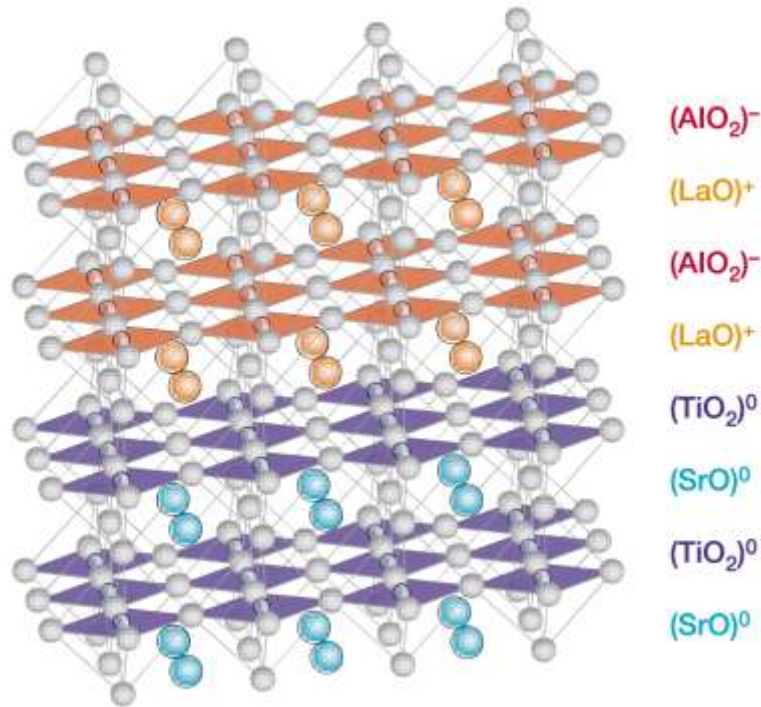
($5 \sim 30 \text{ \AA}$)
Chemical Shift
DOS
Band Diagram



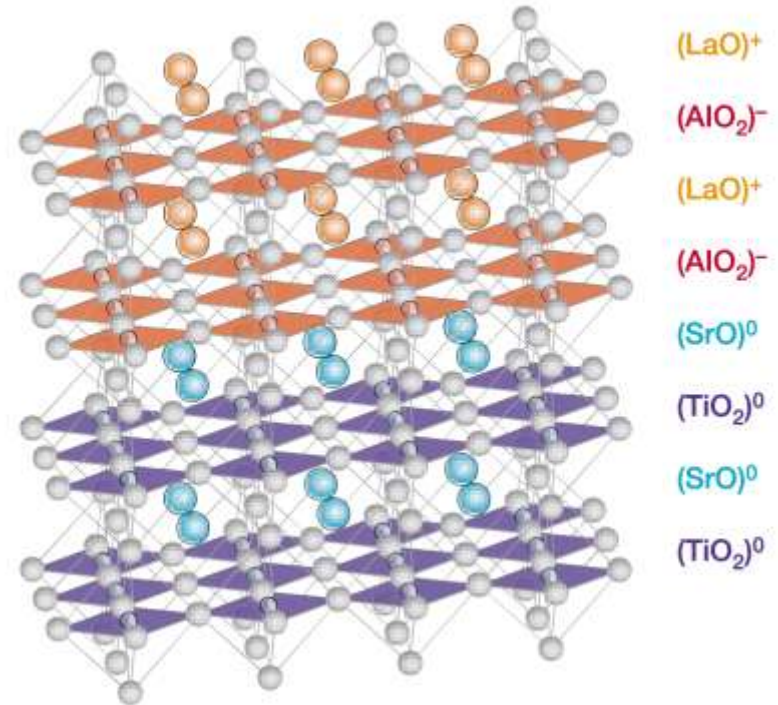
In-situ PES + Laser MBE system



Interfacial Electronic Structure of $\text{LaAlO}_3/\text{SrTiO}_3$ Heterojunctions



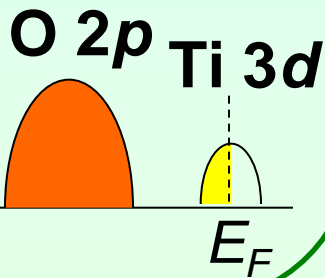
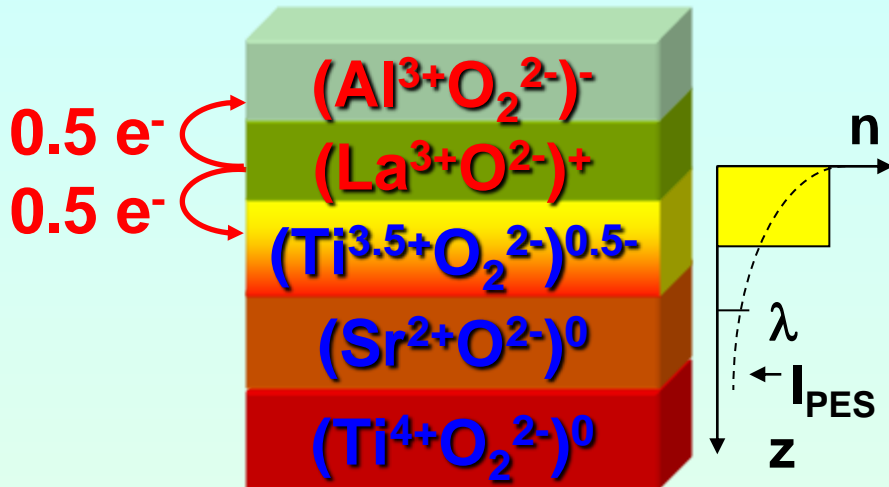
n-type (Metallic)



p-type (Insulating)

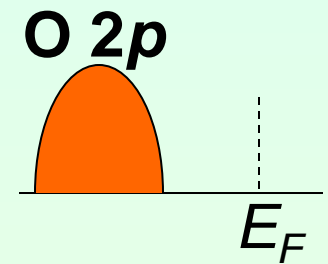
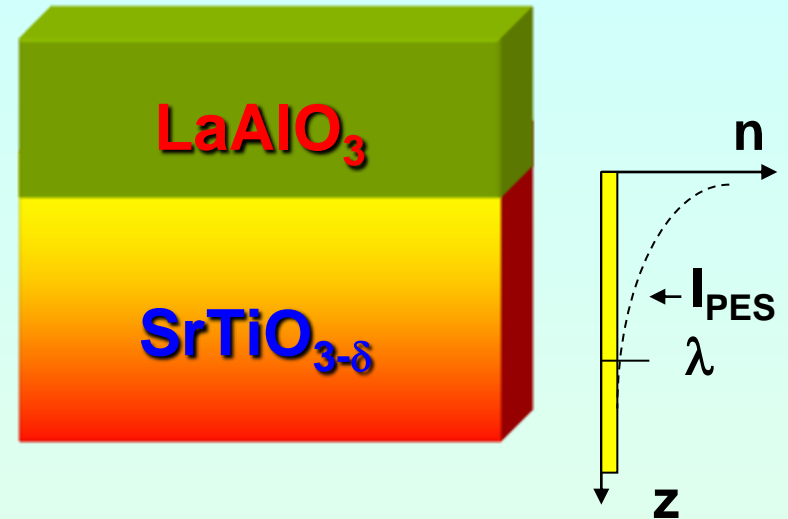
Origin of the Metallic Interface

1. Charge Transfer



N. Nakagawa *et al.*,
Nature Mater. **5**, 204
(2006).

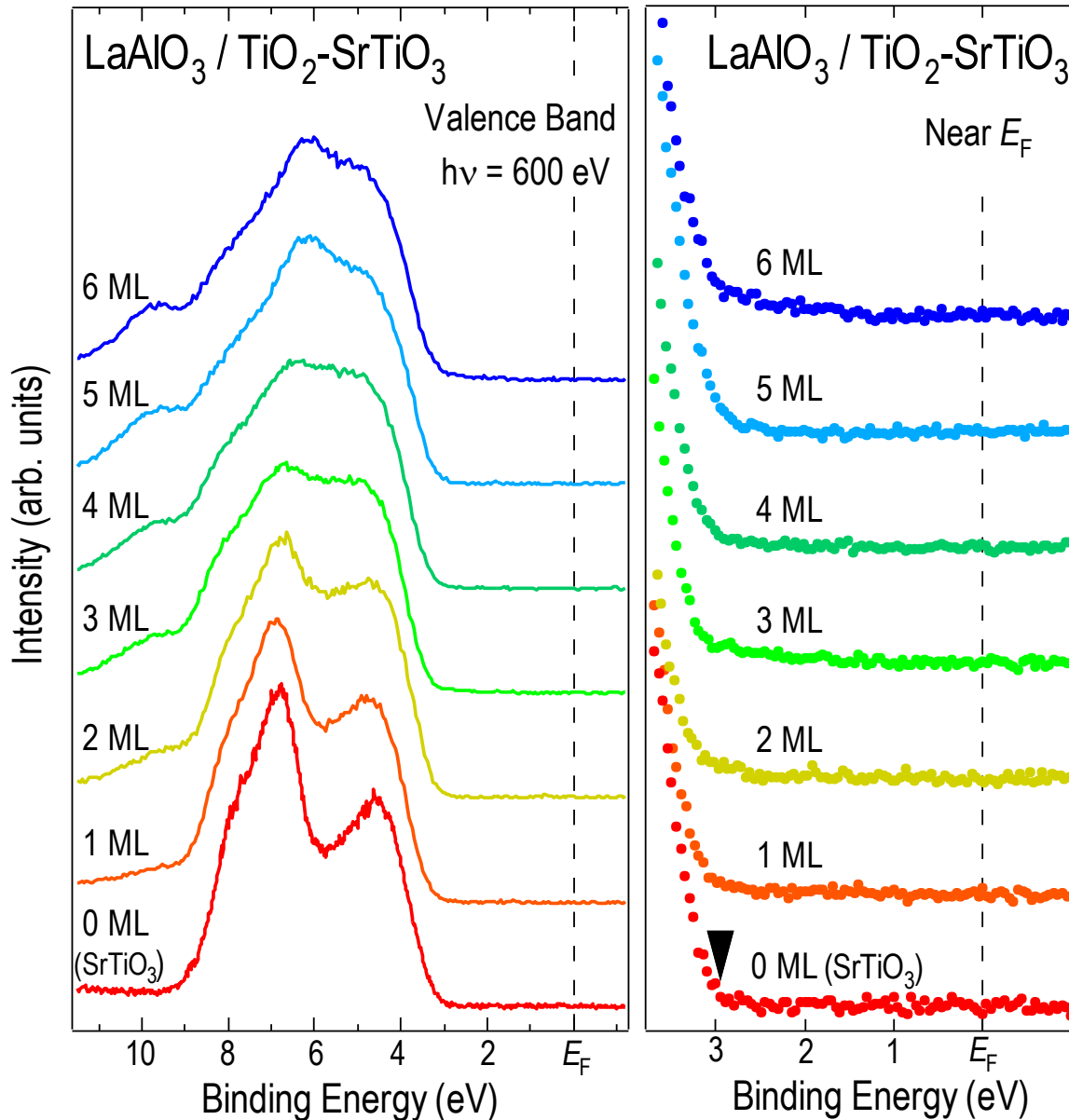
2. Oxygen Vacancies



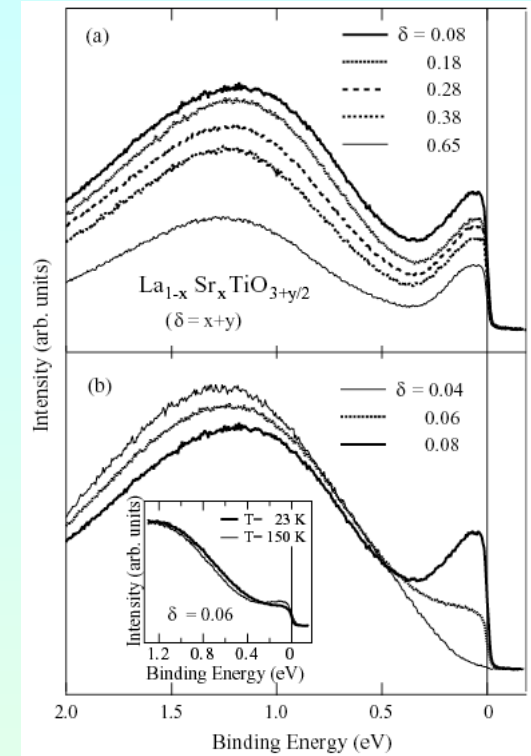
W. Simons *et al.*,
Phys. Rev. Lett. **98**,
196802 (2007).

DOS at E_F is different between the two scenarios.

Valence Band Spectra of n-type Interfaces



PES spectra of LSTO

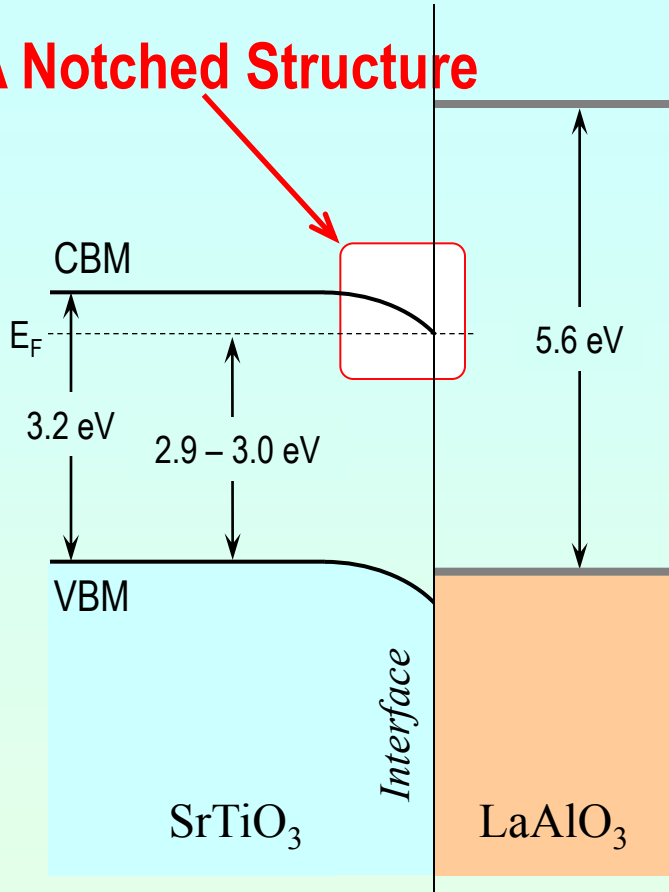


T. Yoshida *et al.*, *Europhys. Lett.* **59**, 258 ('02)

**No detectable
Ti 3d DOS at E_F**

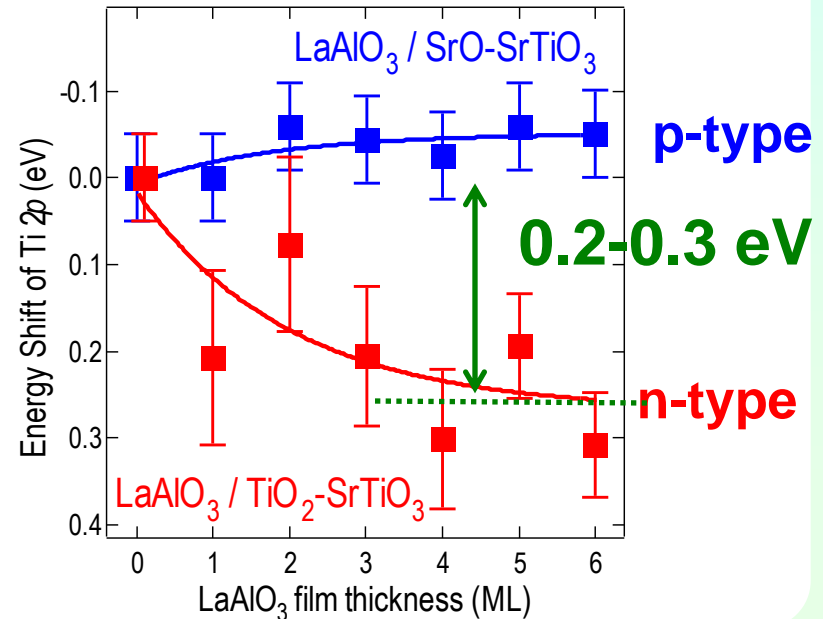
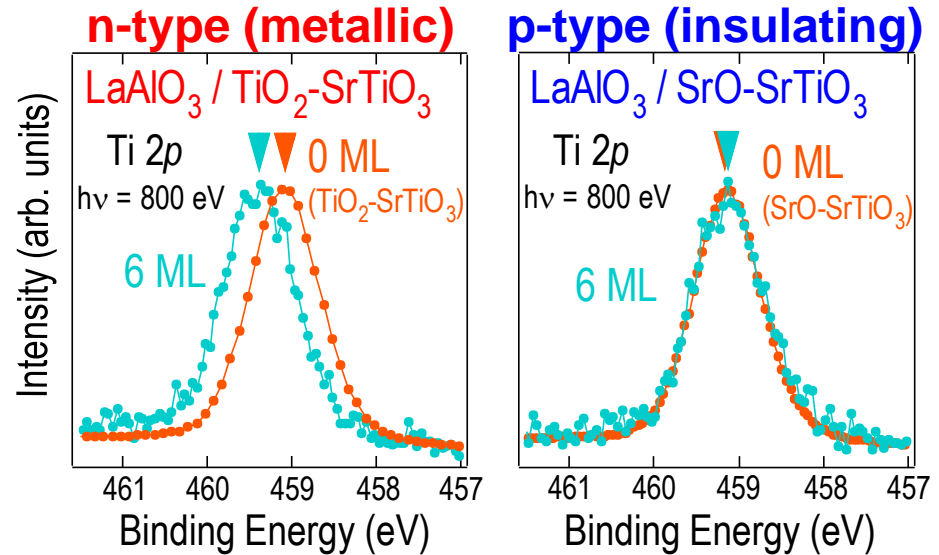
Band Diagram of LAO/STO Interface

A Notched Structure



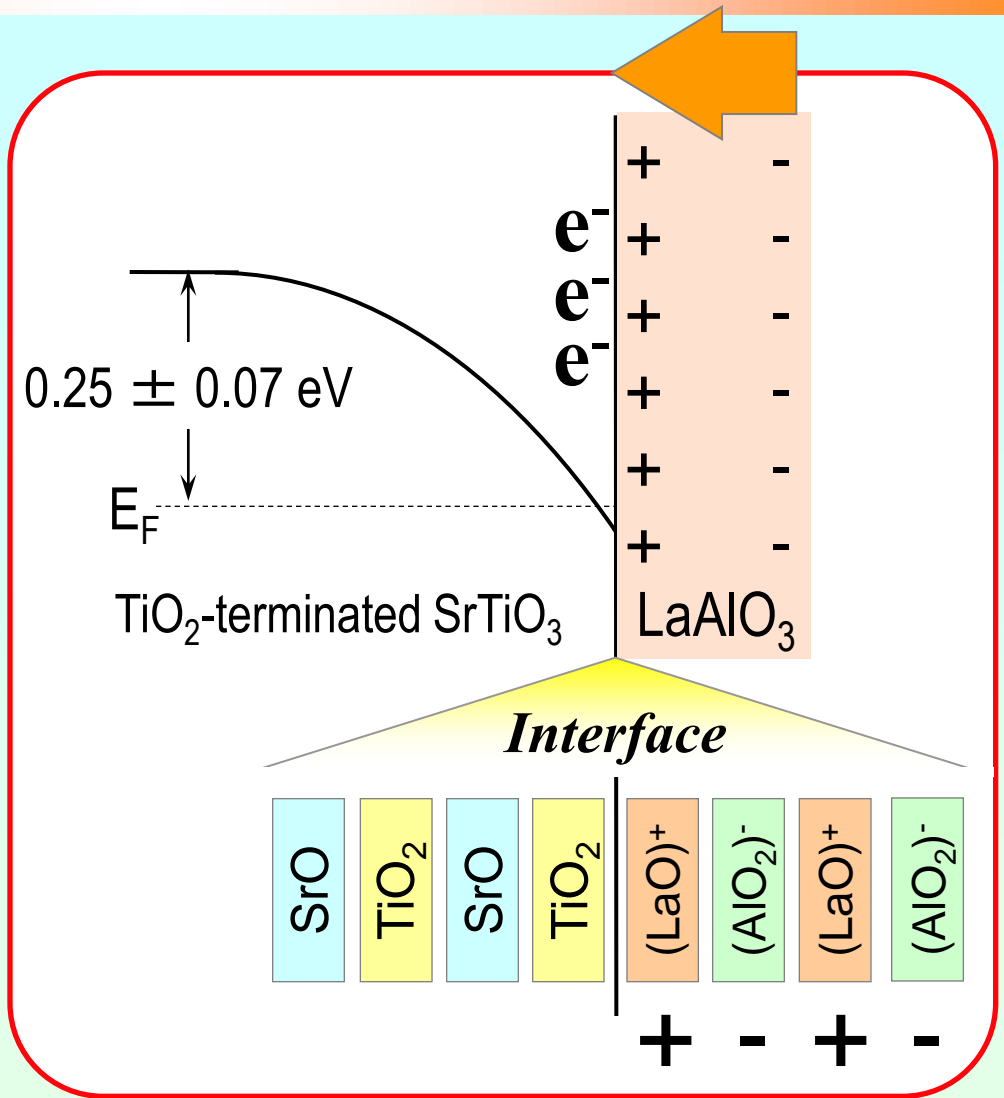
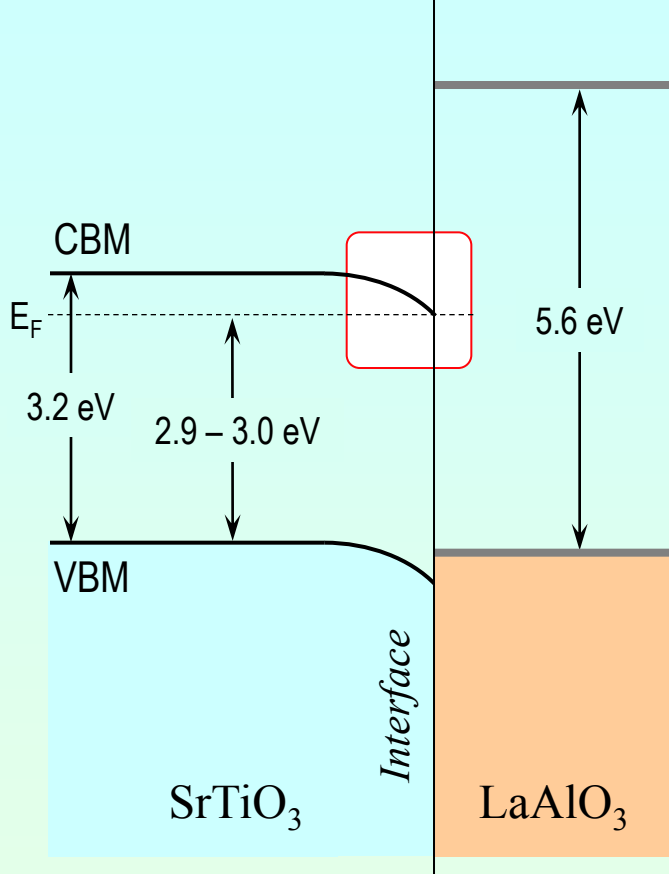
Band bending of 0.2-0.3 eV to higher binding energy from STO to the metallic interface.

Ti 2p core level spectra



Origin of Metallic Conductivity in LAO/STO

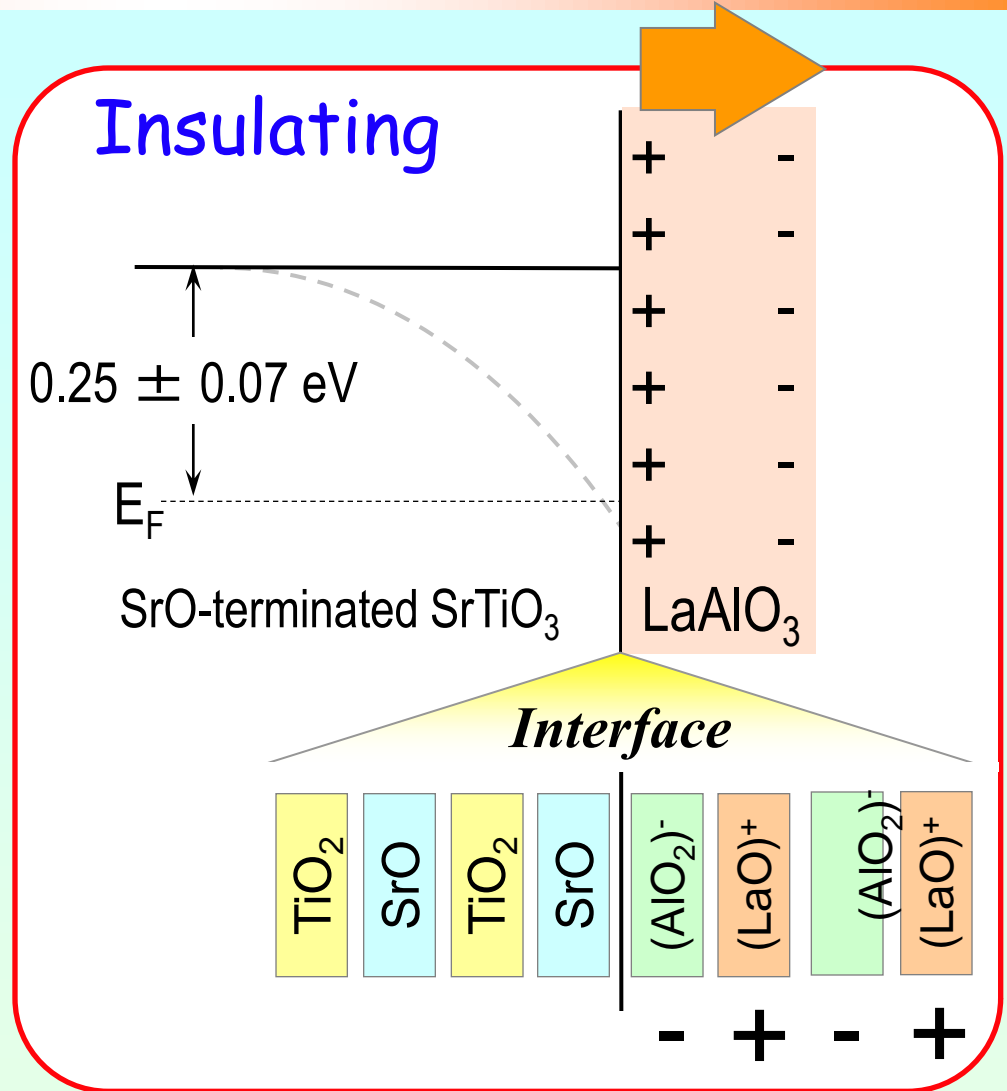
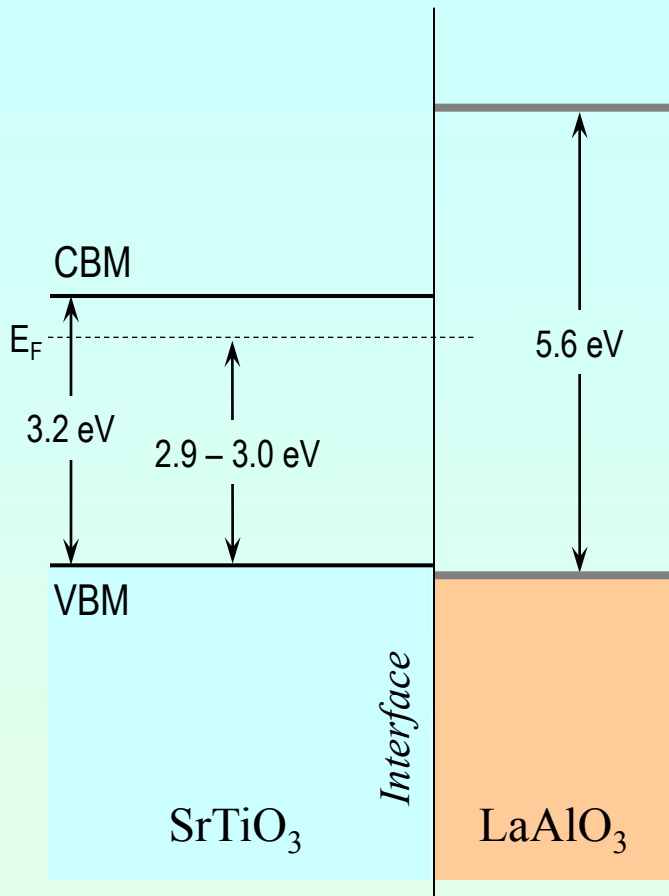
A Notched Structure



K. Yoshimatsu, HK *et al.*, *Phys. Rev. Lett.* **101**, 026802 (08).

The metallic conductivity originates from the accumulation of carriers on the notched structure formed at the interface.

Origin of M-I Transition by Inserting SrO



K. Yoshimatsu, HK *et al.*, *Phys. Rev. Lett.* **101**, 026802 (08).

The notched structure disappears by inserting SrO atomic layer between LAO and STO.

まとめ

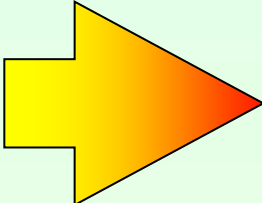
LaserMBE装置と光電子分光装置を連結したin-situ光電子分光装置を立ち上げ、酸化物ヘテロ構造について調べた。

1. LSMO/LSFO, LSMO/STO

界面を通じた遷移金属イオンの電荷移動は3d準位の位置と占有数で決まる。

2. LAO/STO

界面を通じた電荷移動は起こっておらず、金属伝導の起源は界面に形成されたノッチ構造への電子の蓄積である。



放射光の「元素選択性」を用いた放射光電子分光は酸化物ヘテロ構造の研究に非常に有効

We desire

UNDULATOR

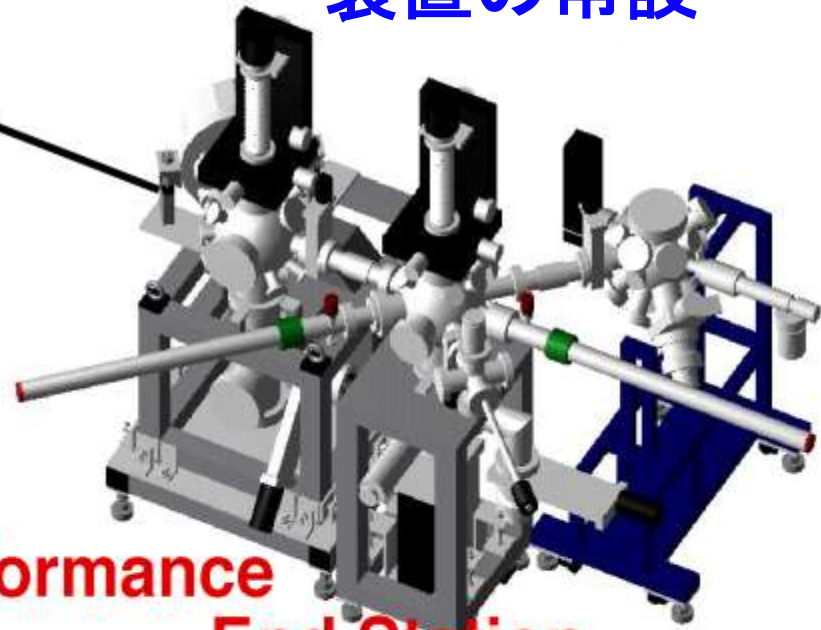
ビームラインの
安定性

長期ビームタイム
装置の常設

High Photon-Flux

&

High Energy Resolution



High-Performance
End Station

使いやすい装置
(ユーザーインターフェース)

解析プログラムの整備

for in-situ PES